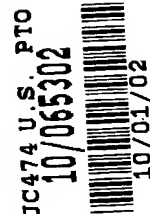


Electronic Filing System (EFS) Data
Electronic Patent Application Submission
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EFS ID: 18468
Application ID: 10065302
Title of Invention: COMPOSITION AND CHEMICAL
VAPOR DEPOSITION METHOD FOR
FORMING ORGANIC LOW K
DIELECTRIC FILMS
First Named Inventor: Neil Hendricks
Domestic/Foreign Application: Domestic Application
Filing Date: null
Effective Receipt Date: 2002-10-01
Submission Type: Utility Patent Filing
Filing Type: new-utility
Confirmation Number: 0
Attorney Docket Number: ATMI-466
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Total Fees Authorized: \$1508.0
Payment Category: DA - Deposit Account
Deposit Account Number: 500860
Deposit Account Name: Margaret Chappuis



TRANSMITTAL FORM

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Number:

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466

Submission Type: Utility Patent
Filing

COMPOSITION AND CHEMICAL VAPOR DEPOSITION METHOD FOR FORMING ORGANIC LOW K DIELECTRIC FILMS

First Named Inventor: Mr. Neil H Hendricks

SUBMITTED BY

Name:	Ms. Margaret Chappuis
Registration Number:	45,735
Electronic Signature Mark: Margaret Chappuis	Date Signed: 20021001

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Attached Files:

specification	466spec.xml
ibid-transmittal	466subpapersapds.xml

fee-transmittal

466subpapersfee.xml

Comments:

FEE TRANSMITTAL

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Patent fees are subject to annual revisions on or about October 1st of each year.

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TOTAL FEES AUTHORIZED: \$ 1508

The commissioner is hereby authorized to charge indicated processing and/or publication fees and credit any overpayments to:

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Charge Any Additional Fee Required Under 37 C.F.R. Sections 1.16 and 1.17.

Charge Assignment Fees Required Under 37 C.F.R. Section 1.21 (h).

SUBMITTED BY

Authorized Name: Margaret Chappuis

Electronic Signature Mark: Margaret Chappuis

Date Signed: 20021001

BASIC FILING FEE

Fee Description	Fee Code	Fee Paid
Utility Filing Fee	101	\$ 740

Subtotal For Basic Filing Fee: \$ 740

EXTRA CLAIM FEES

	Fee Code	Fee	Extra Claims	Fee Paid
Total Claims: 44	103	\$ 18	24	\$ 432
Independent Claims: 7	102	\$ 84	4	\$ 336

10065302 10065302

Subtotal For Extra Claims Fees: \$ 768